



Attorney's Docket No.: 42390P10059CD

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application for:

Ilan Gavish, et al.

Serial No.: 10/632,582

Filed: July 31, 2003

For: FOCUSED ION BEAM DEPOSITION

Examiner: Parviz Hassanzadeh

Art Group: 1763

Confirmation No.: 5004

DO NOT Enter
p.l
2-10-05

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF
Commissioner for Patents
Post Office Box 1450
Alexandria, Virginia 22313-1450

Entered with
RCE 5/9/05
MW 5/12/05

Sir:

In response to the Final Office Action mailed November 8, 2004, Applicants respectfully request entry of the amendments set forth below and consideration of the remarks that follow.